NL940 • NL310 • APL2200 • APL2100 • Nd:Glass

Nd:Glass SYSTEMS



160 J @ 1053 nm MM laser system

Ekspla offers wide range of high energy Nd:Glass laser systems. Typically Nd:Glass laser comprise SLM diode pumped master oscillator, pre-amplifier, pulse shaper and main lamp pumped amplifiers.

SPECIFICATIONS

Parameter	Value
Center wavelength	1053 – 1060 nm
Pulse width	500 ps – 20 ns
Max pulse energy single channel	150 J
Beam spatial profile (near field)	"Top Hat" across 80% of beam cross-section (beam local intensity fluctuation max ±20% from the average intensity)
Pulse repetition rates	depending on system configuration from 1 shot in 1 min to 1 shot in 20 min for output energies >10 J
Shot to shot stability	below 2.0% rms @ fundamental in single channel configuration
Linewidth	<0.02 cm ⁻¹ @ 2 ns for single longitudinal mode (SLM), <1 cm ⁻¹ @ 4 ns for multimode (MM)
Pre-pulse contrast	better than 1 : 10 ⁵
Polarization contrast	>100:1
Output isolation from back-reflected light	>500 : 1 (Faraday isolator contrast)
Optical pulse jitter	typical <0.2 ns RMS, optional <10 ps RMS
Flashlamp lifetime	2×10 ⁵ shots typical (typically >3000 hours of non-stop operation at PRR 1 shot/minute)
Pump diode lifetime	>10 000 hours typical

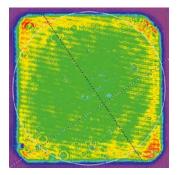
Nanosecond High Energy Laser Systems

FEATURES

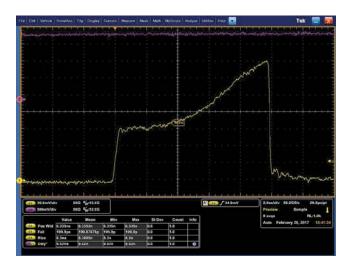
- ► Front end options
 - Diode pumped SLM or MM master oscillator featuring excellent stability, live time and maintenance-free operation based on Nd:glass or Nd:YLF
 - Temporally shaped seeder / regenerative amplifier configuration allowing application of smoothing technics
 - Wave front correction system based on DFM
- Optional SBS compressor ensuring high contrast pulses and controllable pulse duration
- Flashlamp / LD pumped pre-amplifier
- ► Up to Ø60 mm aperture Nd:glass power amplifiers
- ► Laser protection by Faraday isolators preventing damage of laser rods by back-reflected light
- ► Optimized design for maximum pulse energy extraction
- ► Separately controlled PFN circuits for each flash lamp
- Diagnostics and monitoring of system status based on microprocessor controller
- ➤ Software guide for step-by-step performance check at designated control points
- Optional second and third harmonics generators



PERFORMANCE

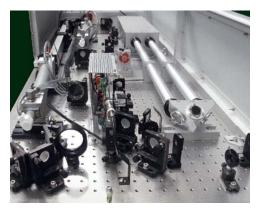


Spatial shaping of 33 J @ 1053 nm output pulses (beam of rectangular shape)



One example of the pulse wave form at the output @ 33 J (fundamental)

CUSTOM INSTALATIONS



Amplifier system delivering 1 J at center wavelength 1060 nm, pulse width 800 ps and ~ 4 nm (FWHM) gain bandwidth



12 J @ 527 nm laser system during development stage



30 J Nd:glass system featuring arbitrary shaped temporal pulse shape